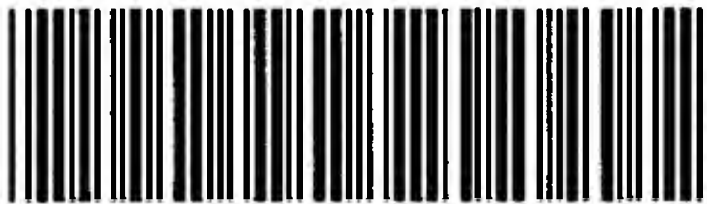


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/707,535	KNEEZEL, GARY A.	
	Examiner	Art Unit	
	Krishnan S. Menon	1723	

SEARCHED			
Class	Subclass	Date	Examiner
210	498	3/29/2006	KM

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Inventor search 347/93 210/498, 510.1, 321.84, 321.75, 488, 490	3/29/2006	KM
update	5/17/2006	KM
Interference search: (fluid and filter and (orientation near3 dependent etch\$3) and passage and substrate).clm.	11/9/2006	KM